Inventor(s): Lin, et al Serial No.: To Be Assigned Filed: Herewith

For: Direct Detection Of Dielectric Etch System ... Malfunctions Attorney Docket No.: 67,200-464

FIG 1A

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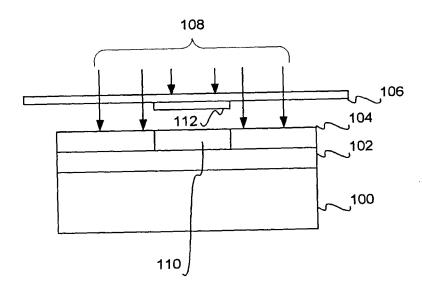
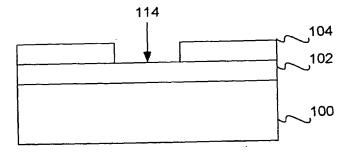


FIG 1B



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FIG 1C

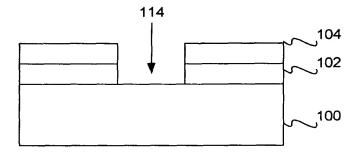
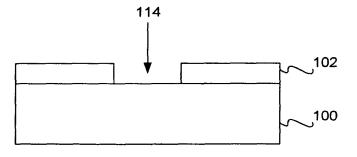
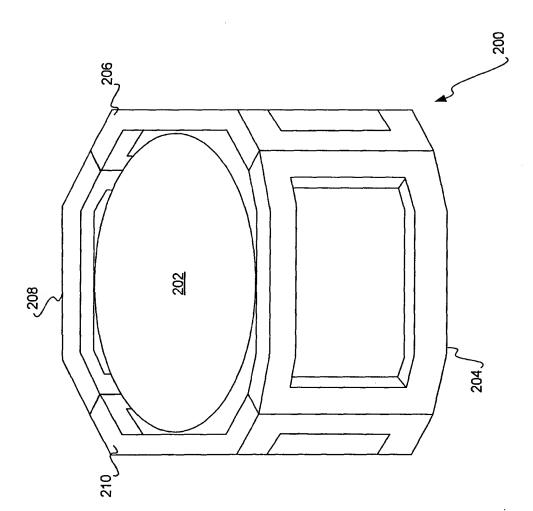


FIG 1D

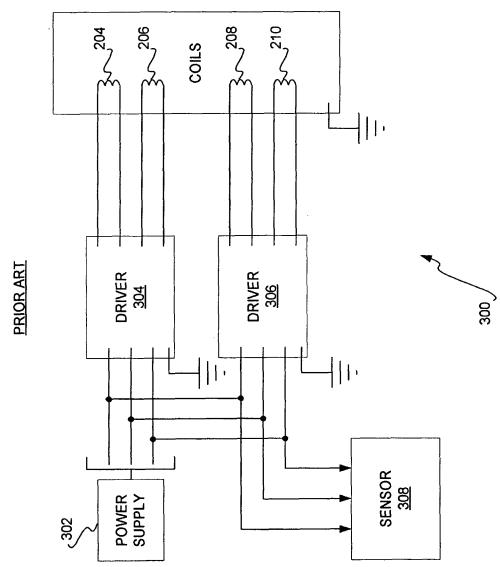


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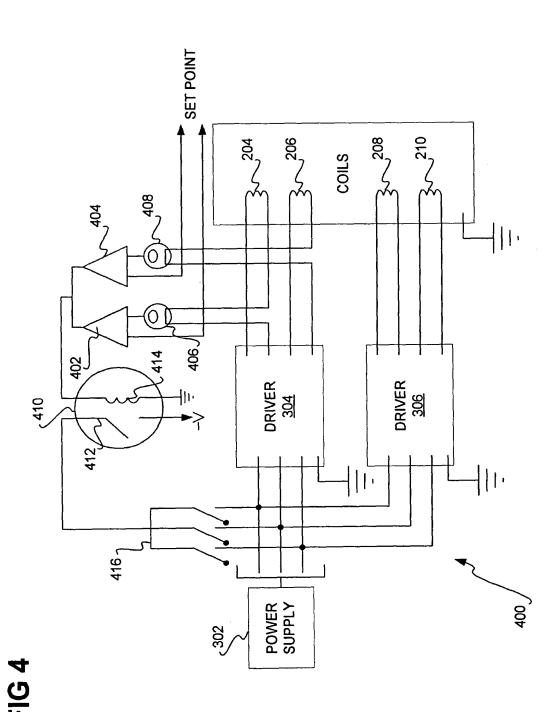
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